

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No.09/475,545
Priority Filing Date December 30, 1999
Inventor Michael T. Andreas
Assignee..... Micron Technology, Inc.
Priority Group Art Unit 3723
Priority Examiner G. Nguyen
Attorney's Docket No.MI22-1881
Title: Chemical-Mechanical Polishing Methods

PRELIMINARY AMENDMENT

To: Box PATENT APPLICATION
Assistant Commissioner for Patents
Washington, D.C. 20231

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)
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AMENDMENTS

In the Specification

At p. 1, before the "Technical Field" section, insert

--RELATED PATENT DATA

This patent resulted from a divisional application of U.S. Patent Application Serial No.
09/475,545, filed on December 30, 1999.--

In The Claims

Please cancel claims 1-25 and 39-70 without prejudice.

EL 844053658

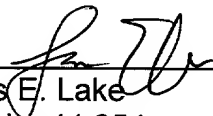
REMARKS

Claims 1-25 and 39-70 are canceled. Claims 26-38 are pending in the application.

Examination of claims 26-38 is requested.

Respectfully submitted,

Dated: 20 Nov 2001

By: 
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